

Amendment Under 37 C.F.R. § 1.116 Group Art Unit 2881, Expedited Procedure

00862.022032.

## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)
	: Examiner: J. Berman
HIROSHI TSUJI ET AL.	)
	: Group Art Unit: 2881
Application No.: 09/691,234	)
	:
Filed: October 19, 2000	)
For: ELECTRON BEAM LITHOGRAPHY	
APPARATUS	: October 6, 2003
Mail Stop AF	
Commissioner for Patents	
P.O. Box 1450	
Alexandria, VA 22313-1450	
.1	

## AMENDMENT AFTER FINAL REJECTION AND PETITION FOR EXTENSION OF TIME

Sir:

Applicants petition to extend the time for response to the Office Action of

June 4, 2003, to and including Saturday, October 4, 2003. A check in the amount of

\$110.00 in payment of the extension fee is enclosed. Please charge any additional fee and

credit any overpayment to our Deposit Account 06-1205.

10/10/2003 SSITHIB1 00000012 09691234

02 FC:1201 03 FC:1202 1032.00 OP 324.00 OP

10/10/2003 SSITHIB1 00000012 09691234 110.00 OP 01 FC:1251

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on October 6, 2003.

(Date of Deposit) NK A. DeLUCIA, JR. (REG. #42,476) (Name of Attorney for Applicant) October 6, 2003 Date of Signature Signature

In response to that Office Action, please amend the above-identified application as follows.

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The claims are listed beginning at page 3. The Remarks begin at page 19.

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